

520.41995CX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. ONO, et al  
Serial No.: (not yet assigned)  
Filed: February 20, 2004  
For: PLASMA PROCESSING METHOD AND PLASMA  
PROCESSING APPARATUS

**REAFFIRMATION OF CLAIM FOR PRIORITY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 20, 2004

Sir:

Under the provisions of 35 USC §119 and 37 CFR §1.55, Applicants hereby claim the right of priority based on Japanese Patent Application No. 2002-125187, filed in Japan on April 26, 2002.

The certified copy of the above-referred to Japanese Patent Application was filed on November 4, 2002, in prior application Serial No. 10/229,034, filed August 28, 2002.

Respectfully submitted,



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